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=> d que 124
L1      1 SEA FILE=REGISTRY ABB=ON PLU=ON "CARBON DIOXIDE"/CN
L2      5 SEA FILE=REGISTRY ABB=ON PLU=ON F2O2S/MF
L3      52 SEA FILE=REGISTRY ABB=ON PLU=ON CO2/MF
L4      17 SEA FILE=REGISTRY ABB=ON PLU=ON (12769-73-2/CRN OR 2699-79-8/
CRN OR 640723-20-2/CRN OR 855587-99-4/CRN OR 855588-00-0/CRN)
L5      22 SEA FILE=REGISTRY ABB=ON PLU=ON L4 OR L2
L6      1396 SEA FILE=REGISTRY ABB=ON PLU=ON (10375-58-3/CRN OR 10375-59-4
/CRN OR 104120-67-4/CRN OR 1111-72-4/CRN OR 113869-22-0/CRN OR
12181-61-2/CRN OR 12351-94-9/CRN OR 124-38-9/CRN OR 12709-62-5/
CRN OR 138832-57-2/CRN OR 14485-07-5/CRN OR 182349-88-8/CRN OR
182349-91-3/CRN OR 18983-82-9/CRN OR 20201-82-5/CRN OR
20273-05-6/CRN OR 20273-06-7/CRN OR 22377-27-1/CRN OR 24285-82-
3/CRN OR 243144-23-2/CRN OR 243144-24-3/CRN OR 243144-25-4/CRN
OR 243144-26-5/CRN OR 243144-27-6/CRN OR 243144-28-7/CRN OR
243144-29-8/CRN OR 2537-69-1/CRN OR 2684-00-6/CRN OR 270063-98-
4/CRN OR 301299-78-5/CRN OR 31530-57-1/CRN OR 318953-55-8/CRN
OR 34715-42-9/CRN OR 37210-16-5/CRN OR 37961-43-6/CRN OR
39399-66-1/CRN OR 51-90-1/CRN OR 60605-62-1/CRN OR 60730-47-4/C
RN OR 60934-58-9/CRN OR 61812-10-0/CRN OR 644976-48-7/CRN OR
68404-37-5/CRN OR 70881-43-5/CRN OR 73145-42-3/CRN OR 75042-80-
7/CRN OR 75042-81-8/CRN OR 791121-04-5/CRN OR 85401-75-8/CRN
OR 875829-71-3/CRN OR 942078-48-0/CRN OR 94951-00-5/CRN) OR L3
L7      85 SEA FILE=CPLUS ABB=ON PLU=ON L5 AND L6
L8      4 SEA FILE=CPLUS ABB=ON PLU=ON L7 AND REM+NT/RL
L9      82 SEA FILE=CPLUS ABB=ON PLU=ON L1 AND L2
L10     4 SEA FILE=CPLUS ABB=ON PLU=ON L8 AND L9
L11     4 SEA FILE=CPLUS ABB=ON PLU=ON L8 OR L10
L12     16428 SEA FILE=CPLUS ABB=ON PLU=ON L6(L) (PURIF? OR REMOV? OR
REM/RL OR PUR/RL)
L13     5 SEA FILE=CPLUS ABB=ON PLU=ON L7 AND L12
L14     35 SEA FILE=CPLUS ABB=ON PLU=ON L5(L) (PURIF? OR PUR/RL OR
REMOV? OR REM/RL)
L15     5 SEA FILE=CPLUS ABB=ON PLU=ON L14 AND L7
L16     5 SEA FILE=CPLUS ABB=ON PLU=ON L11 OR L13 OR L15
```

L17 10 SEA FILE=CAPLUS ABB=ON PLU=ON L7 AND (REMOV? OR PURIF?)  
 L18 11 SEA FILE=CAPLUS ABB=ON PLU=ON L17 OR L16  
 L19 17 SEA FILE=CAPLUS ABB=ON PLU=ON L7 AND (REMOV? OR PURIF? OR  
     ?IMPUR?)  
 L20 18 SEA FILE=CAPLUS ABB=ON PLU=ON L19 OR L18  
 L21 66 SEA FILE=CAPLUS ABB=ON PLU=ON ("SOMMER C"/AU OR "SOMMER C  
     A"/AU OR "SOMMER C C"/AU OR "SOMMER C IRENE"/AU OR "SOMMER C  
     J"/AU OR "SOMMER C M"/AU OR "SOMMER C S"/AU OR "SOMMER  
     CHRISTOPH"/AU OR "SOMMER CHRISTOPHER"/AU OR "SOMMER CHRISTOPHER  
     C"/AU OR "SOMMER CHRISTOPHER CHARLES"/AU)  
 L22 2 SEA FILE=CAPLUS ABB=ON PLU=ON L21 AND ?SULF? AND ?FLUOR?  
 L23 1 SEA FILE=CAPLUS ABB=ON PLU=ON L22 AND L20  
 L24 18 SEA FILE=CAPLUS ABB=ON PLU=ON L20 OR L23

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L24 ANSWER 1 OF 18 CAPLUS COPYRIGHT 2007 ACS on STN  
 ACCESSION NUMBER: 2007:1061068 CAPLUS Full-text  
 DOCUMENT NUMBER: 147:396347  
 TITLE: Apparatus and process for surface treatment of a  
       substrate using an activated reactive gas  
 INVENTOR(S): Garg, Diwakar; Krouse, Steven Arnold; Robertson, Eric  
               Anthony, III; Ma, Pingping  
 PATENT ASSIGNEE(S): USA  
 SOURCE: U.S. Pat. Appl. Publ., 33pp., Cont.-in-part of U.S.  
       Ser. No. 80,330.  
 CODEN: USXXCO  
 DOCUMENT TYPE: Patent  
 LANGUAGE: English  
 FAMILY ACC. NUM. COUNT: 2  
 PATENT INFORMATION:

| PATENT NO.  | KIND | DATE     | APPLICATION NO. | DATE     |
|---|------|----------|-----------------|----------|
| US 2007218204   | A1   | 20070920 | US 2007-689074  | 20070321 |
| US 2006062914   | A1   | 20060323 | US 2005-80330   | 20050315 |
| WO 2006034130   | A2   | 20060330 | WO 2005-US33370 | 20050920 |
| WO 2006034130   | A3   | 20060803 |                 |          |
| W: AE, AG, AL, AM, AT, AU, AZ, BA, BB, BG, BR, BW, BY, BZ, CA, CH,<br>CN, CO, CR, CU, CZ, DE, DK, DM, DZ, EC, EE, EG, ES, FI, GB, GD,<br>GE, GH, GM, HR, HU, ID, IL, IN, IS, JP, KE, KG, KM, KP, KR, KZ,<br>LC, LK, LR, LS, LT, LU, LV, LY, MA, MD, MG, MK, MN, MW, MX, MZ,<br>NA, NG, NI, NO, NZ, OM, PG, PH, PL, PT, RO, RU, SC, SD, SE, SG,<br>SK, SL, SM, SY, TJ, TM, TN, TR, TT, TZ, UA, UG, US, UZ, VC, VN,<br>YU, ZA, ZM, ZW                     |      |          |                 |          |
| RW: AT, BE, BG, CH, CY, CZ, DE, DK, EE, ES, FI, FR, GB, GR, HU, IE,<br>IS, IT, LT, LU, LV, MC, NL, PL, PT, RO, SE, SI, SK, TR, BF, BJ,<br>CF, CG, CI, CM, GA, GN, GQ, GW, ML, MR, NE, SN, TD, TG, BW, GH,<br>GM, KE, LS, MW, MZ, NA, SD, SL, SZ, TZ, UG, ZM, ZW, AM, AZ, BY,<br>KG, KZ, MD, RU, TJ, TM  |      |          |                 |          |
| WO 2007035460   | A1   | 20070329 | WO 2006-US35962 | 20060913 |
| W: AE, AG, AL, AM, AT, AU, AZ, BA, BB, BG, BR, BW, BY, BZ, CA, CH,<br>CN, CO, CR, CU, CZ, DE, DK, DM, DZ, EC, EE, EG, ES, FI, GB, GD,<br>GE, GH, GM, HN, HR, HU, ID, IL, IN, IS, JP, KE, KG, KM, KN, KP,<br>KR, KZ, LA, LC, LK, LR, LS, LT, LU, LV, LY, MA, MD, MG, MK, MN,<br>MW, MX, MY, MZ, NA, NG, NI, NO, NZ, OM, PG, PH, PL, PT, RO, RS,<br>RU, SC, SD, SE, SG, SK, SL, SM, SV, SY, TJ, TM, TN, TR, TT, TZ,<br>UA, UG, US, UZ, VC, VN, ZA, ZM, ZW |      |          |                 |          |
| RW: AT, BE, BG, CH, CY, CZ, DE, DK, EE, ES, FI, FR, GB, GR, HU, IE,   |      |          |                 |          |

IS, IT, LT, LU, LV, MC, NL, PL, PT, RO, SE, SI, SK, TR, BF, BJ,  
 CF, CG, CI, CM, GA, GN, GQ, GW, ML, MR, NE, SN, TD, TG, BW, GH,  
 GM, KE, LS, MW, MZ, NA, SD, SL, SZ, TZ, UG, ZM, ZW, AM, AZ, BY,  
 KG, KZ, MD, RU, TJ, TM

PRIORITY APPLN. INFO.: US 2004-612060P P 20040921  
 US 2005-80330 A2 20050315  
 WO 2005-US33370 A 20050920  
 WO 2006-US35962 A 20060913

AB An apparatus for treatment of a substrate with an activated reactive gas includes a processing chamber, an exhaust manifold, a conveyor adapted to sequentially introduce into the processing chamber untreated portions of the substrate for said treatment and to sequentially remove from the processing chamber treated portions of the substrate, wherein the length of the substrate exceeds a dimension of the inner volume of the processing chamber, and a distribution conduit disposed in the processing chamber. The length of the distribution conduit is approx. equal to the width of the substrate, and the distribution conduit has a number (N) of openings, each opening has a cross sectional area (Ao), a cross sectional area of the distribution conduit (Ac), and a maximum cross-sectional area ( $N \cdot Ao$ ) of the openings can be determined by the following expression:  $1.0 \cdot Ac > N \cdot Ao \geq 0.1 \cdot Ac$ .

INCL 427255110; 118723000R; 118729000; 427248100

CC 76-3 (Electric Phenomena)

IT 75-44-5, Carbonyl chloride 75-46-7, Trifluoromethane 75-73-0, Carbon fluoride (CF<sub>4</sub>) 76-16-4 76-19-7 115-25-3, Carbon fluoride (C<sub>4</sub>F<sub>8</sub>) 124-38-9, Carbon dioxide, processes 334-99-6 335-01-3 335-42-2 353-50-4, Carbonic difluoride 353-85-5 359-40-0, Ethanediyl difluoride 373-91-1 421-14-7 630-08-0, Carbon monoxide, processes 927-84-4 1495-50-7, Cyanogen fluoride ((CN)F) 1718-18-9 2551-62-4, Sulfur fluoride (SF<sub>6</sub>) 2699-79-8, Sulfur fluoride oxide (SF<sub>2</sub>O<sub>2</sub>) 7647-01-0, Hydrogen chloride, processes 7664-39-3, Hydrofluoric acid, processes 7732-18-5, Water, processes 7782-41-4, Fluorine, processes 7782-44-7, Oxygen, processes 7782-50-5, Chlorine, processes 7783-42-8, Sulfur fluoride oxide (SF<sub>2</sub>O) 7783-44-0, Dioxygen difluoride 7783-54-2, Nitrogen fluoride (NF<sub>3</sub>) 7783-60-0, Sulfur fluoride (SF<sub>4</sub>) 7787-71-5, Bromine fluoride (BrF<sub>3</sub>) 7790-91-2, Chlorine fluoride (ClF<sub>3</sub>) 10024-97-2, Nitrous oxide, processes 10025-85-1, Nitrogen chloride (NC<sub>13</sub>) 10028-15-6, Ozone, processes 10102-43-9, Nitric oxide, processes 10102-44-0, Nitrogen dioxide, processes 10294-34-5, Boron chloride (BC<sub>13</sub>) 11094-71-6, Nitrogen fluoride oxide (NFO) 12763-66-5, Hypofluorite 13637-87-1, Nitrogen chloride fluoride (NC<sub>1</sub>F<sub>2</sub>) 13709-36-9, Xenon fluoride (XeF<sub>2</sub>) 15861-05-9, Fluoroamine 16282-67-0 16829-28-0, Oxygen fluoride ((O<sub>3</sub>)F<sub>2</sub>) 16984-48-8, Fluoride, processes 17417-38-8, Nitrogen chloride fluoride (NC<sub>1</sub>2F) 33660-75-2 53912-00-8

RL: PEP (Physical, engineering or chemical process); PROC (Process)  
 (reactive gas; apparatus and process for surface treatment of substrate using activated reactive gas)

IT 124-38-9, Carbon dioxide, processes 2699-79-8, Sulfur fluoride oxide (SF<sub>2</sub>O<sub>2</sub>)

RL: PEP (Physical, engineering or chemical process); PROC (Process)  
 (reactive gas; apparatus and process for surface treatment of substrate using activated reactive gas)

RN 124-38-9 CAPLUS

CN Carbon dioxide (CA INDEX NAME)

o=c=o

RN 2699-79-8 CAPLUS  
 CN Sulfuryl fluoride (CA INDEX NAME)



L24 ANSWER 2 OF 18 CAPLUS COPYRIGHT 2007 ACS on STN  
 ACCESSION NUMBER: 2006:1175017 CAPLUS Full-text  
 DOCUMENT NUMBER: 147:179967  
 TITLE: Analytical method of oxygen isotope compositions in sulfates  
 AUTHOR(S): Wan, De-fang; Li, Yan-he  
 CORPORATE SOURCE: Key Laboratory of Metallogeny and Mineral Resources Assessment, Institute of Mineral Resources, CAGS, Beijing, 100037, Peop. Rep. China  
 SOURCE: Gaoxiao Dizhi Xuebao (2006), 12(3), 378-383  
 CODEN: GDXUFV; ISSN: 1006-7493  
 PUBLISHER: Gaoxiao Dizhi Xuebao Bianjibu  
 DOCUMENT TYPE: Journal  
 LANGUAGE: Chinese

AB Sulfates were a sort of ordinary minerals in the supergene and endo-genetic geol. environment. They were among the few minerals that showed mass independent fractionation of O isotopes. The O isotopic compns. and mass independent fractionation of sulfates could provide useful information for their formation conditions, and reveal special processes that could not be acquired by element concentration or single isotope ratio measurements. This was a frontier and hot topic for isotope geochem. study in the world. Because anal. techniques of O isotopes in sulfates were very complicated, this method was not established until now in China. A traditional BrF5 fluorination method for O isotope measurement of BaSO4 was established recently in the laboratory. The separation and purification processes for BaSO4 from sulfate-bearing samples were described. The BrF5 exptl. equipment, purification technique of reagent BrF5, O2 extraction preparation from sulfates and O isotope measurement were introduced. The O isotope compns. of an international standard of BaSO4 NBS-127, and a chemical reagent of BaSO4 were repeatedly measured. The  $\delta^{18}\text{O}$ -SMOW values of NBS-127 were  $0.920 \pm 0.011\%$ , which was the same as the published standard values. The  $\delta^{18}\text{O}$ -SMOW values of the chemical reagent BaSO4 were  $1.464 \pm 0.013\%$ . The anal. precision of O isotope ratios of BaSO4 was up to  $0.013\%$  ( $1\sigma$ ), and better than  $0.015\text{--}0.029\%$  ( $1\sigma$ ) reported by Wasserman (1992).

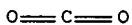
CC 79-1 (Inorganic Analytical Chemistry)  
 IT 124-38-9P, Carbon dioxide, analysis  
 RL: ANT (Analyte); SPN (Synthetic preparation); ANST (Analytical study);  
 PREP (Preparation)  
 (anal. method of oxygen isotope compns. in sulfates)  
 IT 2699-79-8, Sulfuryl fluoride 7787-32-8, Barium fluoride  
 7787-71-5, Bromine trifluoride  
 RL: FMU (Formation, unclassified); FORM (Formation, nonpreparative)  
 (anal. method of oxygen isotope compns. in sulfates)  
 IT 124-38-9P, Carbon dioxide, analysis  
 RL: ANT (Analyte); SPN (Synthetic preparation); ANST (Analytical study);

## PREP (Preparation)

(anal. method of oxygen isotope compns. in sulfates)

RN 124-38-9 CAPLUS

CN Carbon dioxide (CA INDEX NAME)



IT 2699-79-8, Sulfuryl fluoride

RL: FMU (Formation, unclassified); FORM (Formation, nonpreparative)  
(anal. method of oxygen isotope compns. in sulfates)

RN 2699-79-8 CAPLUS

CN Sulfuryl fluoride (CA INDEX NAME)



L24 ANSWER 3 OF 18 CAPLUS COPYRIGHT 2007 ACS on STN

ACCESSION NUMBER: 2006:677935 CAPLUS Full-text

DOCUMENT NUMBER: 145:106172

TITLE: Preparation of nitrogen trifluoride gas of high purity

INVENTOR(S): Chun, Gyeong U.

PATENT ASSIGNEE(S): Dai Beck Co., Ltd., S. Korea

SOURCE: Repub. Korean Kongkae Taeho Kongbo, No pp. given

CODEN: KRXXA7

DOCUMENT TYPE: Patent

LANGUAGE: Korean

FAMILY ACC. NUM. COUNT: 1

## PATENT INFORMATION:

| PATENT NO.             | KIND | DATE     | APPLICATION NO. | DATE     |
|------------------------|------|----------|-----------------|----------|
| KR 2004011884          | A    | 20040211 | KR 2002-45173   | 20020731 |
| PRIORITY APPLN. INFO.: |      |          | KR 2002-45173   | 20020731 |

AB Nitrogen trifluoride (NF<sub>3</sub>) gas of high purity is prepared by removing impurities, such as HF, N<sub>2</sub>F<sub>2</sub>, OF<sub>2</sub>, N<sub>2</sub>O, CO<sub>2</sub> and SO<sub>2</sub>F<sub>2</sub>, and moisture from NF<sub>2</sub> synthetic gas by (a) treating NF<sub>3</sub> with an aqueous KOH solution, thereby converting HF into KF salt which is removed; (b) pyrolyzing N<sub>2</sub>F<sub>2</sub> into nitrogen and fluorine gases at 240-300°; (c) of reducing and removing OF<sub>2</sub> and F<sub>2</sub> by adding a reducing agent, especially K<sub>2</sub>S<sub>2</sub>O<sub>3</sub>; (d) primarily removing moisture by condensing NF<sub>3</sub> at the f.p. using an ethylene glycol based refrigerant; (e) secondarily removing moisture in the NF<sub>3</sub> synthetic gas at ≤ -80° using a moisture adsorbent made of zeolite; (f) removing traces of N<sub>2</sub>O, CO<sub>2</sub> and SO<sub>2</sub>F<sub>2</sub> at ambient temperature using a mol. sieve as an adsorbent; and (g) obtaining NF<sub>3</sub> of high purity by exhausting N<sub>2</sub> and O<sub>2</sub> gases generated by the previous steps and condensing NF<sub>3</sub> gas.

IC ICM C01B021-083

CC 49-8 (Industrial Inorganic Chemicals)

ST nitrogen trifluoride purifn adsorption redn pyrolysis

condensation  
IT 7782-41-4, Fluorine, processes  
RL: CPS (Chemical process); FMU (Formation, unclassified); PEP (Physical, engineering or chemical process); REM (Removal or disposal); FORM (Formation, nonpreparative); PROC (Process)  
(preparing nitrogen trifluoride gas of high purity)  
IT 7664-39-3, Hydrofluoric acid, processes 7783-41-7, Oxygen difluoride  
RL: CPS (Chemical process); PEP (Physical, engineering or chemical process); REM (Removal or disposal); PROC (Process)  
(preparing nitrogen trifluoride gas of high purity)  
IT 124-38-9, Carbon dioxide, processes 2699-79-8, Sulfur  
fluoride oxide (SF<sub>2</sub>O<sub>2</sub>) 10024-97-2, Nitrogen oxide (N<sub>2</sub>O), processes  
RL: PEP (Physical, engineering or chemical process); PYP (Physical process); REM (Removal or disposal); PROC (Process)  
(preparing nitrogen trifluoride gas of high purity)  
IT 10578-16-2, Nitrogen fluoride (N<sub>2</sub>F<sub>2</sub>)  
RL: CPS (Chemical process); PEP (Physical, engineering or chemical process); REM (Removal or disposal); PROC (Process)  
(thermal decomposition; preparing nitrogen trifluoride gas of high purity)  
IT 124-38-9, Carbon dioxide, processes 2699-79-8, Sulfur  
fluoride oxide (SF<sub>2</sub>O<sub>2</sub>)  
RL: PEP (Physical, engineering or chemical process); PYP (Physical process); REM (Removal or disposal); PROC (Process)  
(preparing nitrogen trifluoride gas of high purity)  
RN 124-38-9 CAPLUS  
CN Carbon dioxide (CA INDEX NAME)

$\text{O}=\text{C}=\text{O}$

RN 2699-79-8 CAPLUS  
CN Sulfuryl fluoride (CA INDEX NAME)



L24 ANSWER 4 OF 18 CAPLUS COPYRIGHT 2007 ACS on STN  
ACCESSION NUMBER: 2005:975624 CAPLUS Full-text  
DOCUMENT NUMBER: 143:250603  
TITLE: Purification of sulfuryl  
fluoride  
INVENTOR(S): Sommer, Christoph  
PATENT ASSIGNEE(S): Solvay Fluor GmbH, Germany  
SOURCE: Eur. Pat. Appl., 5 pp.  
CODEN: EPXXDW  
DOCUMENT TYPE: Patent  
LANGUAGE: German  
FAMILY ACC. NUM. COUNT: 1  
PATENT INFORMATION:

| PATENT NO.  | KIND  | DATE     | APPLICATION NO.  | DATE       |
|---|---|----------|------------------|------------|
| EP 1571126  | A1  | 20050907 | EP 2004-5084     | 20040304   |
| R: AT, BE, CH, DE, DK, ES, FR, GB, GR, IT, LI, LU, NL, SE, MC, PT, IE, SI, LT, LV, FI, RO, MK, CY, AL, TR, BG, CZ, EE, HU, PL, SK   |   |          |                  |            |
| WO 2005085128   | A1  | 20050915 | WO 2005-EP1282   | 20050209   |
| W: AE, AG, AL, AM, AT, AU, AZ, BA, BB, BG, BR, BW, BY, BZ, CA, CH, CN, CO, CR, CU, CZ, DE, DK, DM, DZ, EC, EE, EG, ES, FI, GB, GD, GE, GH, GM, HR, HU, ID, IL, IN, IS, JP, KE, KG, KP, KR, KZ, LC, LK, LR, LS, LT, LU, LV, MA, MD, MG, MK, MN, MW, MX, MZ, NA, NI, NO, NZ, OM, PG, PH, PL, PT, RO, RU, SC, SD, SE, SG, SK, SL, SM, SY, TJ, TM, TN, TR, TT, TZ, UA, UG, US, UZ, VC, VN, YU, ZA, ZM, ZW |   |          |                  |            |
| RW: BW, GH, GM, KE, LS, MW, MZ, NA, SD, SL, SZ, TZ, UG, ZM, ZW, AM, AZ, BY, KG, KZ, MD, RU, TJ, TM, AT, BE, BG, CH, CY, CZ, DE, DK, EE, ES, FI, FR, GB, GR, HU, IE, IS, IT, LT, LU, MC, NL, PL, PT, RO, SE, SI, SK, TR, BF, BJ, CF, CG, CI, CM, GA, GN, GQ, GW, ML, MR, NE, SN, TD, TG  |   |          |                  |            |
| EP 1732845  | A1  | 20061220 | EP 2005-701386   | 20050209   |
| R: AT, BE, BG, CH, CY, CZ, DE, DK, EE, ES, FI, FR, GB, GR, HU, IE, IS, IT, LI, LT, LU, MC, NL, PL, PT, RO, SE, SI, SK, TR   |   |          |                  |            |
| CN 1926059  | A   | 20070307 | CN 2005-80006909 | 20050209   |
| US 2007154376   | A1  | 20070705 | US 2006-591554   | 20061009   |
| PRIORITY APPLN. INFO.:  |   |          | EP 2004-5084     | A 20040304 |
|   |   |          | WO 2005-EP1282   | W 20050209 |
| AB  | CO <sub>2</sub> -containing SO <sub>2</sub> F <sub>2</sub> is contacted with a mol. sieve 4 Å at 0-40° and 1-11 bar. Only CO <sub>2</sub> is adsorbed. The loaded mol. sieve may be regenerated in vacuum or in an inert gas flow (e.g., N <sub>2</sub> ) at ≥150°. |          |                  |            |
| IC  | ICM C01B017-46  |          |                  |            |
|   | ICS B01J020-18; B01D053-04; C01B039-02; C01B037-02  |          |                  |            |
| CC  | 49-5 (Industrial Inorganic Chemicals)   |          |                  |            |
| ST  | sulfuryl fluoride purifn carbon dioxide removal   |          |                  |            |
| IT  | Molecular sieves<br>(adsorbent for removal of carbon dioxide impurity from sulfuryl fluoride)   |          |                  |            |
| IT  | 2699-79-8P, Sulfuryl fluoride<br>RL: PUR (Purification or recovery); PREP (Preparation)<br>(purification by removal of carbon dioxide on mol. sieve)  |          |                  |            |
| IT  | 124-38-9, Carbon dioxide, processes<br>RL: REM (Removal or disposal); PROC (Process)<br>(removal of carbon dioxide impurity from sulfuryl fluoride on mol. sieve)   |          |                  |            |
| IT  | 2699-79-8P, Sulfuryl fluoride<br>RL: PUR (Purification or recovery); PREP (Preparation)<br>(purification by removal of carbon dioxide on mol. sieve)  |          |                  |            |
| RN  | 2699-79-8 CAPLUS  |          |                  |            |
| CN  | Sulfuryl fluoride (CA INDEX NAME)   |          |                  |            |



IT 124-38-9, Carbon dioxide, processes  
 RL: REM (Removal or disposal); PROC (Process)  
 (removal of carbon dioxide impurity from  
 sulfonyl fluoride on mol. sieve)  
 RN 124-38-9 CAPLUS  
 CN Carbon dioxide (CA INDEX NAME)

o=c=o

REFERENCE COUNT: 5 THERE ARE 5 CITED REFERENCES AVAILABLE FOR THIS RECORD. ALL CITATIONS AVAILABLE IN THE RE FORMAT

L24 ANSWER 5 OF 18 CAPLUS COPYRIGHT 2007 ACS on STN  
 ACCESSION NUMBER: 2005:266905 CAPLUS Full-text  
 DOCUMENT NUMBER: 143:468869  
 TITLE: Experience with the use of sulfur in laser facilities  
 AUTHOR(S): Bagretcov, V. A.; Vinogradsky, L. M.; Kargin, V. A.;  
 Kutcherova, O. N.; Mazurin, I. M.  
 CORPORATE SOURCE: Russia  
 SOURCE: Trudy RFYaTs-VNIIEF (2004), 6, 186-191, 1 plate  
 CODEN: TRRFAM  
 PUBLISHER: RFYaTS-VNIIEF  
 DOCUMENT TYPE: Journal  
 LANGUAGE: Russian  
 AB Research results of SF6 composition and development of the high pure SF6 technol., which were obtained at the fabrication of gas supplying system for I laser Iskra-5" are reported. Results of mass-spectrometer analyses of SF6 on the contents of 26 admixts. are presented. Influence of admixts. on energetic and operational characteristics for I laser installation is analyzed. The technol. of SF6 addnl. purification was developed. High pure SF6 for laser applications was obtained. Besides the works on the creation of special balloons for storage and transportation of high pure gases were carried out.  
 CC 73-10 (Optical, Electron, and Mass Spectroscopy and Other Related Properties)  
 IT Impurities  
 (in sulfur hexafluoride; experience with use of sulfur in laser facilities)  
 IT 74-82-8, Methane, occurrence 74-86-2, Acetylene, occurrence 75-46-7, Trifluoromethane 115-07-1, Propene, occurrence 124-38-9, Carbon dioxide, occurrence 355-42-0, Tetradecafluorohexane 463-58-1, Carbonyl sulfide 630-08-0, Carbon monoxide, occurrence 2699-79-8, Sulfonyl difluoride 7440-37-1, Argon, occurrence 7446-09-5, Sulfur dioxide, occurrence 7664-39-3, Hydrogen fluoride, occurrence 7783-06-4, Hydrogen sulfide, occurrence 7783-41-7, Fluorine oxide f20 7783-61-1, Silicon tetrafluoride 25167-67-3, Butene  
 RL: OCU (Occurrence, unclassified); OCCU (Occurrence)  
 (impurities in sulfur hexafluoride; experience with use of sulfur in laser facilities)  
 IT 124-38-9, Carbon dioxide, occurrence 2699-79-8, Sulfonyl difluoride  
 RL: OCU (Occurrence, unclassified); OCCU (Occurrence)  
 (impurities in sulfur hexafluoride; experience with use of sulfur in laser facilities)  
 RN 124-38-9 CAPLUS  
 CN Carbon dioxide (CA INDEX NAME)

$\text{O}=\text{C}=\text{O}$

RN 2699-79-8 CAPLUS  
 CN Sulfuryl fluoride (CA INDEX NAME)



L24 ANSWER 6 OF 18 CAPLUS COPYRIGHT 2007 ACS on STN  
 ACCESSION NUMBER: 2002:832312 CAPLUS Full-text  
 DOCUMENT NUMBER: 138:116112  
 TITLE: Spark decomposition of SF<sub>6</sub>, SF<sub>6</sub>/N<sub>2</sub> (10: 90 and 5: 95) mixtures in the presence of solid additives (polyethylene, polypropylene or Teflon), gaseous additives (methane, ethylene, octafluoropropane, carbon monoxide or dioxide), water or oxygen  
 AUTHOR(S): Casanova, A. M.; Diaz, J.; Casanova, J.  
 CORPORATE SOURCE: CPAT, UMR 5002, Universite Paul Sabatier, Toulouse, 31062, Fr.  
 SOURCE: Journal of Physics D: Applied Physics (2002), 35(20), 2558-2569  
 CODEN: JPAPBE; ISSN: 0022-3727  
 PUBLISHER: Institute of Physics Publishing  
 DOCUMENT TYPE: Journal  
 LANGUAGE: English  
 AB The present paper is a continuation of the studies on the sparking-induced decomposition of SF<sub>6</sub> and SF<sub>6</sub>/N<sub>2</sub> (10: 90) mixts. which have already been carried out in the authors' laboratory, both exptl. and numerically. It concerns the decomposition of SF<sub>6</sub>/N<sub>2</sub> mixts. (100 kPa) containing 100%, 10% or 5% of SF<sub>6</sub>, under high-energy sparks (3.6 J spark<sup>-1</sup>) generated in a 340. cm<sup>3</sup> exptl. cell between a stainless steel point and a stainless steel plane. The authors' attention was focused on the following main byproducts: (SF<sub>4</sub> + SOF<sub>2</sub>), (SOF<sub>4</sub> + SO<sub>2</sub>F<sub>2</sub>), S<sub>2</sub>F<sub>10</sub>, CF<sub>4</sub>, CO and CO<sub>2</sub> which were studied by varying the concentration of the impurities added H<sub>2</sub>O, O<sub>2</sub> (0-0.2%), in the presence of atoms such as H and C released from vaporized solid insulators (polyethylene [C<sub>2</sub>H<sub>4</sub>]<sub>n</sub>, polypropylene [C<sub>3</sub>H<sub>6</sub>]<sub>n</sub>, Teflon [CF<sub>2</sub>]<sub>n</sub>) or from gaseous additives (methane CH<sub>4</sub> (0-4%), ethylene C<sub>2</sub>H<sub>4</sub> (0-2%), octafluoropropane C<sub>3</sub>F<sub>8</sub> (0-5%)), with the aim of simulating the occurrence of sparking in elec. devices, especially along spacers. As SF<sub>6</sub>/CO<sub>2</sub> and SF<sub>6</sub>/N<sub>2</sub>/CO<sub>2</sub> mixts. are reported to be able to constitute promising SF<sub>6</sub> substitutes for industrial applications, the authors also studied the chemical stability of SF<sub>6</sub> and SF<sub>6</sub>/N<sub>2</sub> (5: 95) mixts. in the presence of 0-20% CO<sub>2</sub>. The presence of additives CH<sub>4</sub>, C<sub>2</sub>H<sub>4</sub>, C<sub>3</sub>F<sub>8</sub> or solid insulator (polyethylene, polypropylene, Teflon) leads to lower production of (SF<sub>4</sub> + SOF<sub>2</sub>) and S<sub>2</sub>F<sub>10</sub> in dilute SF<sub>6</sub> than in pure SF<sub>6</sub> when the percentages of additives or the amts. of solid insulator vaporized are high. Concerning the additive CO<sub>2</sub>, the authors observe an increased production of (SOF<sub>4</sub> + SO<sub>2</sub>F<sub>2</sub>) and a formation of large quantities of CO, more pronounced in

SF<sub>6</sub>/N<sub>2</sub> (5: 95) mixts. than in pure SF<sub>6</sub>. In contrast, the presence of CO leads to a lesser degree of decomposition of diluted than undiluted SF<sub>6</sub>.

CC 76-11 (Electric Phenomena)  
 Section cross-reference(s): 38, 67

IT 75-73-0, Carbon fluoride (CF<sub>4</sub>) 2699-79-8, Sulfur fluoride oxide (SF<sub>2</sub>O<sub>2</sub>) 5714-22-7, Sulfur fluoride (S<sub>2</sub>F<sub>10</sub>) 7783-42-8, Sulfur fluoride oxide (SF<sub>2</sub>O) 7783-60-0, Sulfur fluoride (SF<sub>4</sub>) 13709-54-1, Sulfur fluoride oxide (SF<sub>4</sub>O)  
 RL: FMU (Formation, unclassified); FORM (Formation, nonpreparative)  
 (spark decomposition of sulfur fluoride, sulfur fluoride/nitrogen mixts. in presence of solid additives, gaseous additives, water or oxygen)

IT 124-38-9, Carbon dioxide, processes 630-08-0, Carbon monoxide, processes  
 RL: FMU (Formation, unclassified); NUU (Other use, unclassified); PEP (Physical, engineering or chemical process); PYP (Physical process); FORM (Formation, nonpreparative); PROC (Process); USES (Uses)  
 (spark decomposition of sulfur fluoride, sulfur fluoride/nitrogen mixts. in presence of solid additives, gaseous additives, water or oxygen)

IT 2699-79-8, Sulfur fluoride oxide (SF<sub>2</sub>O<sub>2</sub>)  
 RL: FMU (Formation, unclassified); FORM (Formation, nonpreparative)  
 (spark decomposition of sulfur fluoride, sulfur fluoride/nitrogen mixts. in presence of solid additives, gaseous additives, water or oxygen)

RN 2699-79-8 CAPLUS

CN Sulfuryl fluoride (CA INDEX NAME)



IT 124-38-9, Carbon dioxide, processes  
 RL: FMU (Formation, unclassified); NUU (Other use, unclassified); PEP (Physical, engineering or chemical process); PYP (Physical process); FORM (Formation, nonpreparative); PROC (Process); USES (Uses)  
 (spark decomposition of sulfur fluoride, sulfur fluoride/nitrogen mixts. in presence of solid additives, gaseous additives, water or oxygen)

RN 124-38-9 CAPLUS

CN Carbon dioxide (CA INDEX NAME)



REFERENCE COUNT: 28 THERE ARE 28 CITED REFERENCES AVAILABLE FOR THIS RECORD. ALL CITATIONS AVAILABLE IN THE RE FORMAT

L24 ANSWER 7 OF 18 CAPLUS COPYRIGHT 2007 ACS on STN  
 ACCESSION NUMBER: 2002:830812 CAPLUS. Full-text  
 DOCUMENT NUMBER: 137:332543  
 TITLE: Sensitive determination of oxygen and other IR-active contaminants in pure fluorine  
 AUTHOR(S): Brenner, Karoly; Czegledi, Alexander; Ebert, Volker; Teichert, Holger

CORPORATE SOURCE: Entwicklung Spezialgase/Labor, Messer Griesheim GmbH  
 (MG), Krefeld, D-47809, Germany

SOURCE: Chemie Ingenieur Technik (2002), 74(10), 1389-1398

CODEN: CITEAH; ISSN: 0009-286X

PUBLISHER: Wiley-VCH Verlag GmbH & Co. KGaA

DOCUMENT TYPE: Journal

LANGUAGE: German

AB A method was developed for the determination of O<sub>2</sub> in pure F samples by spectroscopic measurements in the near IR (NIR) range. Using as monochromatic light source vertical cavity surface emitting laser (VCSEL) diodes and a corrosion resistant stainless steel flow-through absorption cell an absorption spectrometer was constructed. Traces of O in F or other corrosive gases were determined at 761 nm with sensitivities <100 ppmv and a high time resolution ( $\geq 1$  s). On industrial relevant samples the O<sub>2</sub> content in F samples was determined with the developed spectrometer and compared to measurements with Fourier transform IR (FTIR) spectroscopy. Laser spectroscopic measurements performed on compressed gas cylinders showed O<sub>2</sub> concns. of 45-230 ppmv and on produced generator gas concns. of 400-885 ppmv within an operating time of apprx. 5 h of the generator. The FTIR measurements on these samples revealed as typical contaminants HF, CO<sub>2</sub>, COF<sub>2</sub>, SO<sub>2</sub>F<sub>2</sub>, CF<sub>4</sub>, SiF<sub>4</sub>, and SF<sub>6</sub> in a large concentration range. The results are discussed regarding the origin of the contamination in the different F-sources.

CC 79-6 (Inorganic Analytical Chemistry)

ST oxygen impurity detn fluorine near IR spectroscopy

IT Impurities

(O determination and determination of other IR-active contaminants in pure

F)

IT 75-46-7, Trifluoromethane 75-73-0, Tetrafluoromethane 76-16-4,

Hexafluoroethane 124-38-9, Carbon dioxide, analysis 2551-62-4,

Sulfur hexafluoride 2699-79-8, Sulfur fluoride oxide (SF<sub>2</sub>O<sub>2</sub>)

7664-39-3, Hydrofluoric acid, analysis 7782-44-7, Oxygen, analysis

7783-61-1, Silicon fluoride (SiF<sub>4</sub>)

RL: ANT (Analyte); ANST (Analytical study)

(O determination and determination of other IR-active contaminants in pure

F)

IT 124-38-9, Carbon dioxide, analysis 2699-79-8, Sulfur

fluoride oxide (SF<sub>2</sub>O<sub>2</sub>)

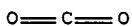
RL: ANT (Analyte); ANST (Analytical study)

(O determination and determination of other IR-active contaminants in pure

F)

RN 124-38-9 CAPLUS

CN Carbon dioxide (CA INDEX NAME)



RN 2699-79-8 CAPLUS

CN Sulfuryl fluoride (CA INDEX NAME)



REFERENCE COUNT: 6 THERE ARE 6 CITED REFERENCES AVAILABLE FOR THIS RECORD. ALL CITATIONS AVAILABLE IN THE RE FORMAT

L24 ANSWER 8 OF 18 CAPLUS COPYRIGHT 2007 ACS on STN  
 ACCESSION NUMBER: 2002:732205 CAPLUS Full-text  
 DOCUMENT NUMBER: 137:388446  
 TITLE: Hazardous materials: Requirements for maintenance, requalification, repair and use of DOT specification cylinders; final rule  
 CORPORATE SOURCE: Research and Special Programs Administration (RSPA), DOT, USA  
 SOURCE: Federal Register (2002), 67(153), 51625-51668, 8 Aug 2002  
 CODEN: FEREAC; ISSN: 0097-6326  
 PUBLISHER: Superintendent of Documents  
 DOCUMENT TYPE: Journal  
 LANGUAGE: English

AB In this final rule, RSPA is amending the requirements of the Hazardous Materials Regulations applicable to the maintenance, requalification, repair, and use of DOT specification cylinders. In addition, RSPA is adopting changes to revise the requirements for approval of cylinder requalifiers, independent inspection agencies, and non-domestic chemical anal. and tests. Further, RSPA is removing authorization for the manufacture of DOT specification cylinders made with aluminum alloy 6351-T6. This action is being taken to simplify the regulations, respond to petitions for rule making, address recommendations of the National Transportation Safety Board, and enhance the safe transportation of hazardous materials in cylinders.

CC 59-5 (Air Pollution and Industrial Hygiene)  
 IT 74-84-0, Ethane, miscellaneous 74-85-1, Ethylene, miscellaneous  
 74-87-3, Methyl chloride, miscellaneous 74-93-1, Methyl mercaptan, miscellaneous 74-99-7D, Methyl acetylene, mixture with propadiene  
 75-01-4, Vinyl chloride, miscellaneous 75-02-5, Vinyl fluoride  
 75-19-4, Cyclopropane 75-37-6, r-152a 75-38-7, r-1132a 75-45-6, r-22  
 75-50-3, Trimethylamine, miscellaneous 75-63-8, r-13b1 75-68-3, r-142b  
 75-71-8, r-12 75-72-9, r-13 76-15-3, r-115 124-38-9, Carbon dioxide, miscellaneous 124-40-3, Dimethylamine, miscellaneous  
 460-19-5, Cyanogen 463-49-0D, Propadiene, mixture with Me acetylene  
 2551-62-4, Sulfur hexafluoride 2696-92-6, Nitrosyl chloride  
 2699-79-8, Sulfuryl fluoride 7446-09-5, Sulfur dioxide, miscellaneous 7647-01-0, Hydrogen chloride, miscellaneous 7664-39-3, Hydrogen fluoride, miscellaneous 7664-41-7, Ammonia, miscellaneous  
 7782-50-5, Chlorine, miscellaneous 7782-65-2, Germane 7783-06-4, Hydrogen sulfide, miscellaneous 10024-97-2, Nitrous oxide, miscellaneous  
 13463-39-3, Nickel carbonyl 13463-40-6, Iron pentacarbonyl 56275-41-3, r-500  
 RL: MSC (Miscellaneous)  
 (requirements for maintenance, requalification, repair and use of DOT specification cylinders)  
 IT 124-38-9, Carbon dioxide, miscellaneous 2699-79-8, Sulfuryl fluoride  
 RL: MSC (Miscellaneous)  
 (requirements for maintenance, requalification, repair and use of DOT specification cylinders)  
 RN 124-38-9 CAPLUS  
 CN Carbon dioxide (CA INDEX NAME)

o=c=o

RN 2699-79-8 CAPLUS  
 CN Sulfuryl fluoride (CA INDEX NAME)



L24 ANSWER 9 OF 18 CAPLUS COPYRIGHT 2007 ACS on STN  
 ACCESSION NUMBER: 2002:503185 CAPLUS Full-text

DOCUMENT NUMBER: 137:87570

TITLE: Sensitive determination of oxygen and other IR-active impurities in pure fluorine

AUTHOR(S): Brenner, K.; Czegledi, A.; Ebert, V.; Teichert, H.

CORPORATE SOURCE: Krefeld, Germany

SOURCE: VDI-Berichte (2002), 1667 (Anwendungen und Trends in der Optischen Analysenmesstechnik), 73-80

CODEN: VDIBAP; ISSN: 0083-5560

PUBLISHER: VDI Verlag GmbH

DOCUMENT TYPE: Journal

LANGUAGE: German

AB A compact diode laser absorption spectrometer was developed that can quant. detect traces of O<sub>2</sub> in F<sub>2</sub> with high sensitivity (<100 ppmv) and time resolution ( $\geq 1$  s). This system was tested in a special gasworks in Germany to study whether it was able to measure the O<sub>2</sub> content in industrial F<sub>2</sub> samples along with other heteronuclear impurities. The measurements of compressed gas bottle of F<sub>2</sub> (100%) gave O<sub>2</sub> concns. of 45-230 ppmv. The FTIR measurements showed the presence of HF, CO<sub>2</sub>, COF<sub>2</sub>, SO<sub>2</sub>F<sub>2</sub>, CF<sub>4</sub>, SiF<sub>4</sub>, and SF<sub>6</sub> as typical impurities in a wide range of concns., from % of HF to <0.5 ppmv of SF<sub>6</sub>.

CC 79-6 (Inorganic Analytical Chemistry)

Section cross-reference(s): 73

ST fluorine gas oxygen impurity detn laser absorption spectrometry

IT Impurities

(O and other IR-active impurity determination in pure F)

IT Semiconductor lasers

(O and other IR-active impurity determination in pure F using)

IT Laser spectroscopy

(absorption; O and other IR-active impurity determination in pure F using)

IT Absorption spectroscopy

(laser-induced; O and other IR-active impurity determination in pure F using)

IT Gas sensors

(oxygen; O and other IR-active impurity determination in pure F)

IT 7782-41-4, Fluorine, analysis

RL: AMX (Analytical matrix); ANST (Analytical study)

(O and other IR-active impurity determination in pure F)

IT 75-73-0, Tetrafluoromethane 124-38-9, Carbon dioxide, analysis

353-50-4, Carbon fluoride oxide (COF<sub>2</sub>) 2551-62-4, Sulfur hexafluoride

2699-79-8, Sulfur fluoride oxide (SF<sub>2</sub>O<sub>2</sub>) 7664-39-3, Hydrofluoric acid, analysis 7783-61-1, Silicon tetrafluoride  
 RL: ANT (Analyte); ANST (Analytical study)  
 (O and other IR-active impurity determination in pure F)

IT 7782-44-7, Oxygen, analysis  
 RL: ANT (Analyte); ANST (Analytical study)  
 (sensors; O and other IR-active impurity determination in pure F)

IT 124-38-9, Carbon dioxide, analysis 2699-79-8, Sulfur fluoride oxide (SF<sub>2</sub>O<sub>2</sub>)  
 RL: ANT (Analyte); ANST (Analytical study)  
 (O and other IR-active impurity determination in pure F)

RN 124-38-9 CAPLUS

CN Carbon dioxide (CA INDEX NAME)



RN 2699-79-8 CAPLUS  
 CN Sulfuryl fluoride (CA INDEX NAME)



REFERENCE COUNT: 5 THERE ARE 5 CITED REFERENCES AVAILABLE FOR THIS RECORD. ALL CITATIONS AVAILABLE IN THE RE FORMAT

L24 ANSWER 10 OF 18 CAPLUS COPYRIGHT 2007 ACS on STN  
 ACCESSION NUMBER: 2002:488687 CAPLUS Full-text  
 DOCUMENT NUMBER: 137:225078  
 TITLE: Chemical decomposition of high pressure SF<sub>6</sub>/N<sub>2</sub> (5:95) mixtures under negative DC corona discharges  
 AUTHOR(S): Diaz, Joseph; Casanovas, Anne-Marie; Godard, Christine; Casanovas, Joseph  
 CORPORATE SOURCE: CPAT, UMR 5002, Univ. Paul Sabatier, Toulouse, Fr.  
 SOURCE: Gaseous Dielectrics IX, [Proceedings of the International Symposium on Gaseous Dielectrics], 9th, Ellicott City, MD, United States, May 21-25, 2001 (2001), 543-547. Editor(s): Christophorou, Loucas G.; Olthoff, James K. Kluwer Academic/Plenum Publishers: New York, N. Y.  
 CODEN: 69CUJE; ISBN: 0-306-46705-4  
 DOCUMENT TYPE: Conference  
 LANGUAGE: English  
 AB Under neg. d.c. corona discharges, the main gaseous byproducts of the decomposition of high pressure SF<sub>6</sub>/N<sub>2</sub> mixts. containing 5% SF<sub>6</sub>, with no impurity added, were SOF<sub>4</sub>, SO<sub>2</sub>F<sub>2</sub>, S<sub>2</sub>F<sub>10</sub>, S<sub>2</sub>O<sub>3</sub>F<sub>6</sub>, (SF<sub>5</sub>)<sub>2</sub>NF, and NF<sub>3</sub>. The yields of these gaseous byproducts were generally lower or equal to that produced in the SF<sub>6</sub>/N<sub>2</sub> mixts. containing 10% SF<sub>6</sub>. A small production of N<sub>2</sub>O and CO<sub>2</sub> was also detected.  
 CC 76-11 (Electric Phenomena)

IT 124-38-9, Carbon dioxide, formation (nonpreparative)  
 2699-79-8, Sulfur fluoride oxide (SF<sub>2</sub>O<sub>2</sub>) 5714-22-7, Sulfur  
 fluoride (S<sub>2</sub>F<sub>10</sub>) 7783-54-2, Nitrogen fluoride (NF<sub>3</sub>) 10024-97-2,  
 Nitrogen oxide (N<sub>2</sub>O), formation (nonpreparative) 13709-54-1, Sulfur  
 fluoride oxide (SF<sub>4</sub>O) 81439-35-2 81625-84-5, Sulfur fluoramide  
 fluoride (S<sub>2</sub>(FN)F<sub>10</sub>)  
 RL: FMU (Formation, unclassified); FORM (Formation, nonpreparative)  
 (chemical decomposition of high pressure sulfur fluoride/nitrogen mixts.)

under

neg. DC corona discharges)

IT 124-38-9, Carbon dioxide, formation (nonpreparative)  
 2699-79-8, Sulfur fluoride oxide (SF<sub>2</sub>O<sub>2</sub>)  
 RL: FMU (Formation, unclassified); FORM (Formation, nonpreparative)  
 (chemical decomposition of high pressure sulfur fluoride/nitrogen mixts.)

under

neg. DC corona discharges)

RN 124-38-9 CAPLUS

CN Carbon dioxide (CA INDEX NAME)

O=C=O

RN 2699-79-8 CAPLUS  
 CN Sulfuryl fluoride (CA INDEX NAME)



REFERENCE COUNT: 8 THERE ARE 8 CITED REFERENCES AVAILABLE FOR THIS RECORD. ALL CITATIONS AVAILABLE IN THE RE FORMAT

L24 ANSWER 11 OF 18 CAPLUS COPYRIGHT 2007 ACS on STN  
 ACCESSION NUMBER: 2000:119486 CAPLUS Full-text  
 DOCUMENT NUMBER: 132:174298  
 TITLE: Chemical kinetics modelling of a decaying SF<sub>6</sub> arc plasma in the presence of a solid organic insulator, copper, oxygen and water  
 AUTHOR(S): Coll, I.; Casanovas, A. M.; Vial, L.; Gleizes, A.; Casanovas, J.  
 CORPORATE SOURCE: CPAT-ESA 5002, Universite Paul Sabatier, Toulouse, 31062, Fr.  
 SOURCE: Journal of Physics D: Applied Physics (2000), 33(3), 221-229  
 CODEN: JPAPBE; ISSN: 0022-3727  
 PUBLISHER: Institute of Physics Publishing  
 DOCUMENT TYPE: Journal  
 LANGUAGE: English  
 AB The composition variations occurring in decaying SF<sub>6</sub> arc plasmas in the presence of atoms released from the vaporization of organic insulators (e.g. Teflon, polyethylene, polypropylene, Megelit, Nylon), Cu, O, and water were

studied between 12,000 K and 300 K by a chemical kinetics model. From the results obtained at 300 K and a pressure of 101.3 kPa: (i) the role of the impurities on the formation of the SF<sub>6</sub> decomposition products: SF<sub>4</sub>, SOF<sub>2</sub>, SO<sub>2</sub>F<sub>2</sub>, and S<sub>2</sub>F<sub>10</sub>, was determined; (ii) it was confirmed that the vaporization of an organic insulator leads to the appearance of CF<sub>4</sub> and an increase in the generation of the major byproduct (SF<sub>4</sub> + SOF<sub>2</sub>) which is correlated to the production of CF<sub>4</sub>; (iii) it was seen that, for a given amount of vaporized insulator, insulators that contain F atoms brought about less SF<sub>6</sub> decomposition than those that did not.

- CC 76-11 (Electric Phenomena)  
 Section cross-reference(s): 22, 35, 67
- IT 75-73-0, Carbon tetrafluoride 124-38-9, Carbon dioxide, formation (nonpreparative) 353-50-4, Carbonyl fluoride 630-08-0, Carbon monoxide, formation (nonpreparative) 2699-79-8, Sulfur fluoride oxide (SF<sub>2</sub>O<sub>2</sub>) 5714-22-7, Disulfur decafluoride 7446-09-5, Sulfur dioxide, formation (nonpreparative) 7664-39-3, Hydrofluoric acid, formation (nonpreparative) 7727-37-9, Nitrogen, formation (nonpreparative) 7782-41-4, Fluorine, formation (nonpreparative) 7783-06-4, Hydrogen sulfide, formation (nonpreparative) 7783-41-7, Oxygen difluoride 7783-42-8, Sulfur fluoride oxide (SF<sub>2</sub>O) 7783-60-0, Sulfur tetrafluoride 7789-19-7, Cupric fluoride 12061-70-0, Oxygen monofluoride 13827-32-2, Sulfur monoxide 13940-21-1, Hydrogen sulfide (HS) 14762-94-8, formation (nonpreparative) 17778-88-0, formation (nonpreparative) 20901-21-7, Disulfur monoxide  
 RL: FMU (Formation, unclassified); FORM (Formation, nonpreparative)  
 (chemical kinetics modeling of a decaying SF<sub>6</sub> arc plasma in the presence of a polymeric insulator, Cu, O, and water)
- IT 124-38-9, Carbon dioxide, formation (nonpreparative)  
 2699-79-8, Sulfuryl fluoride oxide (SF<sub>2</sub>O<sub>2</sub>)  
 RL: FMU (Formation, unclassified); FORM (Formation, nonpreparative)  
 (chemical kinetics modeling of a decaying SF<sub>6</sub> arc plasma in the presence of a polymeric insulator, Cu, O, and water)
- RN 124-38-9 CAPLUS
- CN Carbon dioxide (CA INDEX NAME)



- RN 2699-79-8 CAPLUS  
 CN Sulfuryl fluoride (CA INDEX NAME)



REFERENCE COUNT: 19 THERE ARE 19 CITED REFERENCES AVAILABLE FOR THIS RECORD. ALL CITATIONS AVAILABLE IN THE RE FORMAT

L24 ANSWER 12 OF 18 CAPLUS COPYRIGHT 2007 ACS on STN  
 ACCESSION NUMBER: 1997:353999 CAPLUS Full-text  
 DOCUMENT NUMBER: 126:326887

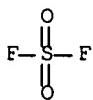
TITLE: Recycling of spent interior space fumigants  
 PATENT ASSIGNEE(S): Binker Materialschutz GmbH, Germany  
 SOURCE: Ger. Offen., 8 pp.  
 CODEN: GWXXBX  
 DOCUMENT TYPE: Patent  
 LANGUAGE: German  
 FAMILY ACC. NUM. COUNT: 1  
 PATENT INFORMATION:

| PATENT NO.  | KIND | DATE     | APPLICATION NO.  | DATE     |
|-------------|------|----------|------------------|----------|
| DE 19540331 | A1   | 19970430 | DE 1995-19540331 | 19951028 |
| DE 19540331 | C2   | 20030220 |                  |          |

PRIORITY APPLN. INFO.: DE 1995-19540331 19951028  
 AB Spent fumigants (CO<sub>2</sub>, sulfuryl chloride, carbonyl sulfide, etc.), used for fumigation of interior spaces (storage rooms, mills, museums, churches, etc.) are separated from the accompanying air and recycled.  
 IC ICM A01M001-20  
 CC 5-4 (Agrochemical Bioregulators)  
 IT 74-88-4P, Methyl iodide, biological studies 124-38-9P, Carbon dioxide, biological studies 463-58-1P, Carbonyl sulfide 2699-79-8P, Sulfuryl fluoride 7791-25-5P, Sulfuryl chloride, RL: BUU (Biological use, unclassified); PUR (Purification or recovery); BIOL (Biological study); PREP (Preparation); USES (Uses) (recycling of, as spent interior space fumigants)  
 IT 124-38-9P, Carbon dioxide, biological studies 2699-79-8P, Sulfuryl fluoride RL: BUU (Biological use, unclassified); PUR (Purification or recovery); BIOL (Biological study); PREP (Preparation); USES (Uses) (recycling of, as spent interior space fumigants)  
 RN 124-38-9 CAPLUS  
 CN Carbon dioxide (CA INDEX NAME)

O—C=O

RN 2699-79-8 CAPLUS  
 CN Sulfuryl fluoride (CA INDEX NAME)



L24 ANSWER 13 OF 18 CAPLUS COPYRIGHT 2007 ACS on STN  
 ACCESSION NUMBER: 1996:134526 CAPLUS Full-text  
 DOCUMENT NUMBER: 124:183147  
 TITLE: Removal of residual impurities in plasma chemical vaporization machining  
 INVENTOR(S): Mori, Juzo; Ichimaru, Hiroshi; Nakagawa, Shinsuke  
 PATENT ASSIGNEE(S): Mori Juzo, Japan; Central Glass Co Ltd

SOURCE: Jpn. Kokai Tokkyo Koho, 4 pp.  
 CODEN: JKXXAF  
 DOCUMENT TYPE: Patent  
 LANGUAGE: Japanese  
 FAMILY ACC. NUM. COUNT: 1  
 PATENT INFORMATION:

| PATENT NO.             | KIND | DATE     | APPLICATION NO. | DATE     |
|------------------------|------|----------|-----------------|----------|
| JP 07331449            | A    | 19951219 | JP 1994-123675  | 19940606 |
| PRIORITY APPLN. INFO.: |      |          | JP 1994-123675  | 19940606 |

AB Residual impurities in plasma chemical vaporization machining using ≥1 halide gas are removed by mixing with an oxidizing agent. The halide gas may be SF<sub>6</sub>, CF<sub>4</sub>, NF<sub>3</sub>, or CCl<sub>4</sub>. The oxidizing agent may be O<sub>2</sub>, O<sub>3</sub>, and/or N<sub>2</sub>O. This method is useful for machining of Si, Ti, etc.

IC ICM C23C016-50  
 ICS B01J019-08

CC 56-6 (Nonferrous Metals and Alloys)

ST plasma chem vaporization machining impurity removal;  
 oxidant chem machining impurity removal

IT Etching  
 Machining  
 Oxidizing agents  
 (removal of residual impurities in plasma chemical vaporization machining)

IT 124-38-9, Carbon dioxide, processes 353-50-4, Carbon oxyfluoride (COF<sub>2</sub>) 2699-79-8, Sulfur oxyfluoride (SO<sub>2</sub>F<sub>2</sub>) 7446-09-5, Sulfur dioxide, processes 7550-45-0, Titanium tetrachloride, processes 7783-61-1, Silicon tetrafluoride 10102-43-9, Nitrogen monoxide, processes 10102-44-0, Nitrogen dioxide, processes 13709-54-1, Sulfur oxyfluoride (SOF<sub>4</sub>)  
 RL: REM (Removal or disposal); PROC (Process)  
 (impurity; removal of residual impurities in plasma chemical vaporization machining)

IT 7782-44-7, Oxygen, uses 10024-97-2, Nitrogen oxide (N<sub>2</sub>O), uses 10028-15-6, Ozone, uses  
 RL: NUU (Other use, unclassified); USES (Uses)  
 (oxidizing agent; removal of residual impurities in plasma chemical vaporization machining)

IT 56-23-5, Carbon tetrachloride, processes 75-73-0, Carbon tetrafluoride 2551-62-4, Sulfur hexafluoride 7440-21-3, Silicon, processes 7440-32-6, Titanium, processes 7782-41-4, Fluorine, processes 7783-54-2, Nitrogen trifluoride  
 RL: PEP (Physical, engineering or chemical process); PROC (Process)  
 (removal of residual impurities in plasma chemical vaporization machining)

IT 124-38-9, Carbon dioxide, processes 2699-79-8, Sulfur oxyfluoride (SO<sub>2</sub>F<sub>2</sub>)  
 RL: REM (Removal or disposal); PROC (Process)  
 (impurity; removal of residual impurities in plasma chemical vaporization machining)

RN 124-38-9 CAPLUS  
 CN Carbon dioxide (CA INDEX NAME)

o=c=o

RN 2699-79-8 CAPLUS  
 CN Sulfuryl fluoride (CA INDEX NAME)



L24 ANSWER 14 OF 18 CAPLUS COPYRIGHT 2007 ACS on STN  
 ACCESSION NUMBER: 1992:268235 CAPLUS Full-text  
 DOCUMENT NUMBER: 116:268235  
 TITLE: Application of a cryospectroscopy method to study the molecular composition of gases  
 AUTHOR(S): Zhigula, L. A.; Kolomiitsova, T. D.; Kondaurov, V. A.; Melikova, S. M.; Shchepkin, D. N.  
 CORPORATE SOURCE: Santkt-Petersburg Gos. Univ., St. Petersburg, USSR  
 SOURCE: Zhurnal Prikladnoi Spektroskopii (1992), 56(3), 381-8  
 CODEN: ZPSBAX; ISSN: 0514-7506  
 DOCUMENT TYPE: Journal  
 LANGUAGE: Russian  
 AB A cryogenic procedure was developed for the sensitive determination of mol. microimpurities in pure and ultrapure gases. IR absorption spectra of liquid air, oxygen as well as of solns. of 20 different substances (hydrocarbons, freons etc.) in liquid argon were investigated. When using optical layers up to 2 m, the sensitivity of the procedure amts. to 10-8-10-4 mol.% from the ground substance. Calibration tables for 27 characteristic impurities are presented.  
 CC 79-6 (Inorganic Analytical Chemistry)  
 Section cross-reference(s): 59  
 IT 74-82-8, Methane, analysis 74-84-0, Ethane, analysis 74-85-1, Ethene, analysis 74-86-2, Acetylene, analysis 75-15-0, Carbon disulfide, analysis 75-46-7, Trifluoromethane 75-69-4, Freon-11 75-71-8, Freon-12 75-72-9, Freon-13 75-73-0, Carbon tetrafluoride 76-16-4, Freon-116 76-19-7, Freon-218 124-38-9, Carbon dioxide, analysis 353-50-4, Carbonic difluoride 463-58-1, Carbon oxide sulfide (COS) 593-53-3 630-08-0, Carbon monoxide, analysis 2314-97-8, Trifluoroiodomethane 2551-62-4, Sulfur hexafluoride 2699-79-8, Sulfur fluoride oxide (SF<sub>2</sub>O<sub>2</sub>) 5714-22-7, Sulfur fluoride (S<sub>2</sub>F<sub>10</sub>) 7783-41-7, Oxygen difluoride 7783-54-2, Nitrogen trifluoride 7783-61-1, Silicon tetrafluoride 10024-97-2, Nitrous oxide, analysis 10028-15-6, Ozone, analysis 13709-54-1  
 RL: ANT (Analyte); ANST (Analytical study)  
 (determination of, in gases by cryogenic IR spectrometry)  
 IT 124-38-9, Carbon dioxide, analysis 2699-79-8, Sulfur fluoride oxide (SF<sub>2</sub>O<sub>2</sub>)  
 RL: ANT (Analyte); ANST (Analytical study)  
 (determination of, in gases by cryogenic IR spectrometry)  
 RN 124-38-9 CAPLUS  
 CN Carbon dioxide (CA INDEX NAME)

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RN 2699-79-8 CAPLUS  
 CN Sulfuryl fluoride (CA INDEX NAME)



L24 ANSWER 15 OF 18 CAPLUS COPYRIGHT 2007 ACS on STN  
 ACCESSION NUMBER: 1989:138075 CAPLUS Full-text  
 DOCUMENT NUMBER: 110:138075  
 TITLE: Refining of sulfur hexafluoride  
 AUTHOR(S): Mazurin, I. M.; Panov, V. V.; Salekhov, L. T.;  
 Shevtsov, A. V.  
 CORPORATE SOURCE: Gos. Nauchno-Issled. Energ. Inst., Moscow, USSR  
 SOURCE: Vysokochistye Veshchestva (1989), (1), 95-101  
 CODEN: VYVEEC; ISSN: 0235-0122  
 DOCUMENT TYPE: Journal  
 LANGUAGE: Russian  
 AB Directional crystallization in liquid N was used for the removal of CO<sub>2</sub>, CF<sub>4</sub>, oil, SO<sub>2</sub>, SO<sub>2</sub>F<sub>2</sub>, C<sub>4</sub>F<sub>6</sub>, SiF<sub>4</sub>, SOF<sub>4</sub>, and other impurities from SF<sub>6</sub>. The sp. energy consumption was 200-250 kJ/kg SF<sub>6</sub> corresponding to 2.5 kg liquid N<sub>2</sub>/kg SF<sub>6</sub>. The concns. of impurities in the initial and final product were determined by mass spectroscopy.  
 CC 49-8 (Industrial Inorganic Chemicals)  
 IT Hydrocarbon oils  
 RL: REM (Removal or disposal); PROC (Process)  
 (removal of, from sulfur hexafluoride, by directional crystallization at cryogenic temperature)  
 IT Crystallization  
 (directional, of sulfur hexafluoride, impurity removal by)  
 IT 75-73-0, Carbon tetrafluoride 124-38-9, Carbon dioxide, uses and miscellaneous 685-63-2 2699-79-8, Sulfuryl fluoride 7446-09-5, Sulfur dioxide, uses and miscellaneous 7783-42-8, Thionyl fluoride 7783-61-1, Silicon tetrafluoride 13709-54-1, Sulfur fluoride oxide (SOF<sub>4</sub>)  
 RL: REM (Removal or disposal); PROC (Process)  
 (removal of, from sulfur hexafluoride, by directional crystallization at cryogenic temperature)  
 IT 124-38-9, Carbon dioxide, uses and miscellaneous 2699-79-8, Sulfuryl fluoride  
 RL: REM (Removal or disposal); PROC (Process)  
 (removal of, from sulfur hexafluoride, by directional crystallization at cryogenic temperature)  
 RN 124-38-9 CAPLUS  
 CN Carbon dioxide (CA INDEX NAME)

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RN 2699-79-8 CAPLUS  
 CN Sulfuryl fluoride (CA INDEX NAME)



L24 ANSWER 16 OF 18 CAPLUS COPYRIGHT 2007 ACS on STN  
 ACCESSION NUMBER: 1986:434744 CAPLUS Full-text  
 DOCUMENT NUMBER: 105:34744  
 TITLE: Determination of impurities in sulfur hexafluoride  
 AUTHOR(S): Wan, Zitzun; Yue, Fupen; Xia, Shugan  
 CORPORATE SOURCE: Beijing Sci.-Res. Inst. Labour Hyg., Beijing, Peop. Rep. China  
 SOURCE: Zhurnal Analiticheskoi Khimii (1986), 41(4), 649-52  
 CODEN: ZAKHA8; ISSN: 0044-4502  
 DOCUMENT TYPE: Journal  
 LANGUAGE: Russian  
 AB Fourteen impurities were identified by mass fragmentog. The compds. were separated at 50° on a 2-m + 3-mm column packed with silica gel coated with 25 weight% diisooctyl sebacate. SOF<sub>2</sub> and SO<sub>2</sub>F<sub>2</sub> were identified also by IR spectrometry and determined by gas chromatog. by using thermal-conductivity and flame-ionization detectors.  
 CC 79-6 (Inorganic Analytical Chemistry)  
 ST sulfur fluoride analysis impurity instrumental; mass fragmentog analysis sulfur fluoride; gas chromatog analysis sulfur fluoride; IR spectrometry analysis sulfur fluoride  
 IT 2699-79-8 7783-42-8  
 RL: ANST (Analytical study)  
 (detection and determination of, in sulfur hexafluoride, instrumental)  
 IT 7446-09-5, analysis 7727-37-9, analysis 7732-18-5, analysis 7782-44-7, analysis 75-73-0 76-16-4 76-19-7 124-38-9, analysis 355-25-9 1873-23-0 42310-84-9  
 RL: ANST (Analytical study)  
 (identification of, in sulfur hexafluoride, mass fragmentog.)  
 IT 2699-79-8  
 RL: ANST (Analytical study)  
 (detection and determination of, in sulfur hexafluoride, instrumental)  
 RN 2699-79-8 CAPLUS  
 CN Sulfuryl fluoride (CA INDEX NAME)



IT 124-38-9, analysis  
 RL: PROC (Process)  
 (identification of, in sulfur hexafluoride, mass fragmentog.)  
 RN 124-38-9 CAPLUS  
 CN Carbon dioxide (CA INDEX NAME)

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L24 ANSWER 17 OF 18 CAPLUS COPYRIGHT 2007 ACS on STN  
 ACCESSION NUMBER: 1966:402253 CAPLUS Full-text  
 DOCUMENT NUMBER: 65:2253  
 ORIGINAL REFERENCE NO.: 65:362c-d  
 TITLE: Separation of sulfuryl fluoride from sulfur hexafluoride containing gas mixtures  
 INVENTOR(S): Massonne, Joachim  
 PATENT ASSIGNEE(S): Kali-Chemie A.-G.  
 SOURCE: 2 pp.  
 DOCUMENT TYPE: Patent  
 LANGUAGE: Unavailable  
 FAMILY ACC. NUM. COUNT: 1  
 PATENT INFORMATION:

| PATENT NO.   | KIND  | DATE     | APPLICATION NO. | DATE     |
|--|---|----------|-----------------|----------|
| DE 1212945   |   | 19660324 | DE 1964-K53405  | 19640707 |
| PRIORITY APPLN. INFO.:   |   |          | DE              | 19640707 |
| AB The gas mixts. to be purified are passed at 20 to 180° over large surfaces of Al2O3, mol. sieves (13 X), solid oxides, hydroxides, or carbonates of the Group I and II elements, or mixts. thereof. Examples with data of the gas concns. and velocities and of thicknesses and shapes of the solids, layers are given. SO2F2 reacts with the named materials producing nonvolatile products at lower temps.: 2 NaOH + SO2F2 → NaSO3F + NaF + H2O; and at higher temps. 2 CaO + SO2F2 → CaSO4 + CaF2. |   |          |                 |          |
| IC   | C01B  |          |                 |          |
| CC   | 17 (Industrial Inorganic Chemicals)   |          |                 |          |
| IT   | 124-38-9, Carbon dioxide<br>(chromatography of, apparatus for)                                  |          |                 |          |
| IT   | 2699-79-8P, Sulfuryl fluoride<br>RL: PREP (Preparation)<br>(separation from gas containing SF6) |          |                 |          |
| IT   | 124-38-9, Carbon dioxide<br>(chromatography of, apparatus for)                                  |          |                 |          |
| RN   | 124-38-9 CAPLUS   |          |                 |          |
| CN   | Carbon dioxide (CA INDEX NAME)  |          |                 |          |

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IT 2699-79-8P, Sulfuryl fluoride  
 RL: PREP (Preparation)  
 (separation from gas containing SF6)

RN 2699-79-8 CAPLUS  
 CN Sulfuryl fluoride (CA INDEX NAME)



L24 ANSWER 18 OF 18 CAPLUS COPYRIGHT 2007 ACS on STN  
 ACCESSION NUMBER: 1963:472022 CAPLUS Full-text  
 DOCUMENT NUMBER: 59:72022  
 ORIGINAL REFERENCE NO.: 59:13353b-e  
 TITLE: Volumetric determination of concentrations of sulfuryl fluoride in air  
 AUTHOR(S): Heuser, Stanley G.  
 CORPORATE SOURCE: Agr. Res. Council, Slough, UK  
 SOURCE: Anal. Chem. (1963), 35(10), 1476-9  
 CODEN: ANCHAM; ISSN: 0003-2700  
 DOCUMENT TYPE: Journal  
 LANGUAGE: Unavailable  
 AB SO<sub>2</sub>F<sub>2</sub> reacts with cold dilute alkali, e.g., 0.1N NaOH, as follows: SO<sub>2</sub>F<sub>2</sub> + 2NaOH → Na-SO<sub>3</sub>F + NaF + H<sub>2</sub>O. This equation is the basis for 2 methods for determination of the concentration of SO<sub>2</sub>F<sub>2</sub> and CO<sub>2</sub> in air. Samples of SO<sub>2</sub>F<sub>2</sub> vapor in air were taken in evacuated (5 cm. of Hg absolute) 200-ml. of 1-l. glass flasks containing a known volume of standard NaOH (0.1N), and allowed to stand for 24 hrs. Method A: 2 ml. of 20% SrCl<sub>2</sub>.6H<sub>2</sub>O is added to an aliquot of the NaOH solution which has reacted with approx. 50 mg. SO<sub>2</sub>F<sub>2</sub>. After precipitation of SrCO<sub>3</sub>, the aliquot is titrated with 0.05N HCl with thymolphthalein as indicator (end point pH 9.2). The difference in titration from that of a reagent blank of the same volume is due to the removal of free alkali by SO<sub>2</sub>F<sub>2</sub> and CO<sub>2</sub>. A correction for CO<sub>2</sub> is made by direct titration at 0°, with the buret tip under the surface to pH 8.3 of excess alkali in another aliquot of the sample without addition of SrCl<sub>2</sub>, with phenoltetrachlorophthalein as indicator (carbonate to-carbonate). This titration volume, when subtracted from a reagent blank is used to calculate the amts. of SO<sub>2</sub>F<sub>2</sub> and CO<sub>2</sub> present. Accuracy = ±2.5% at 50 mg./l. SO<sub>2</sub>F<sub>2</sub>, taking 20 ml. aliquots from 50 ml. in a 1. flask. Method B: 0.1N Ba(OH)<sub>2</sub> is substituted for NaOH in method A. Titration to pH 9.2 gives reduction of free alkali due to SO<sub>2</sub>F<sub>2</sub> and CO<sub>2</sub> as in A. Excess 0.1N HCl, based on the 0.1N Ba(OH)<sub>2</sub>, is added and the solution is back-titrated to pH 5.0 with a mixed indicator (methyl red and bromocresol green). Accuracy = ±0.5% at 10 mg./l. with 1-l. flask. A method is given for correcting the CO<sub>2</sub> content when the concentration is above 1% (20 mg./l.). Data are also presented for the recovery of SO<sub>2</sub>F<sub>2</sub> vs. reaction time and normality of the absorbing solution. The reaction time limits the usefulness for field applications, but the method is useful for the calibration of thermal conductivity instruments commonly used in the field.  
 CC 2 (Analytical Chemistry)  
 IT 124-38-9, Carbon dioxide 2699-79-8, Sulfuryl fluoride (determination of, in air)  
 IT 124-38-9, Carbon dioxide 2699-79-8, Sulfuryl fluoride (determination of, in air)  
 RN 124-38-9 CAPLUS  
 CN Carbon dioxide (CA INDEX NAME)

o=c=o

RN 2699-79-8 CAPLUS  
 CN Sulfuryl fluoride (CA INDEX NAME)



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|     |       |                          |        |  |
|-----|-------|--------------------------|--------|--|
| L1  | 1     | SEA FILE=REGISTRY ABB=ON | PLU=ON | "CARBON DIOXIDE"/CN  |
| L2  | 5     | SEA FILE=REGISTRY ABB=ON | PLU=ON | F2O2S/MF   |
| L3  | 52    | SEA FILE=REGISTRY ABB=ON | PLU=ON | CO2/MF   |
| L4  | 17    | SEA FILE=REGISTRY ABB=ON | PLU=ON | (12769-73-2/CRN OR 2699-79-8/<br>CRN OR 640723-20-2/CRN OR 855587-99-4/CRN OR 855588-00-0/CRN)   |
| L5  | 22    | SEA FILE=REGISTRY ABB=ON | PLU=ON | L4 OR L2   |
| L6  | 1396  | SEA FILE=REGISTRY ABB=ON | PLU=ON | (10375-58-3/CRN OR 10375-59-4/<br>CRN OR 104120-67-4/CRN OR 1111-72-4/CRN OR 113869-22-0/CRN OR<br>12181-61-2/CRN OR 12351-94-9/CRN OR 124-38-9/CRN OR 12709-62-5/<br>CRN OR 138832-57-2/CRN OR 14485-07-5/CRN OR 182349-88-8/CRN OR<br>182349-91-3/CRN OR 18983-82-9/CRN OR 20201-82-5/CRN OR<br>20273-05-6/CRN OR 20273-06-7/CRN OR 22377-27-1/CRN OR 24285-82-<br>3/CRN OR 243144-23-2/CRN OR 243144-24-3/CRN OR 243144-25-4/CRN<br>OR 243144-26-5/CRN OR 243144-27-6/CRN OR 243144-28-7/CRN OR<br>243144-29-8/CRN OR 2537-69-1/CRN OR 2684-00-6/CRN OR 270063-98-<br>4/CRN OR 301299-78-5/CRN OR 31530-57-1/CRN OR 318953-55-8/CRN<br>OR 34715-42-9/CRN OR 37210-16-5/CRN OR 37961-43-6/CRN OR<br>39399-66-1/CRN OR 51-90-1/CRN OR 60605-62-1/CRN OR 60730-47-4/C<br>RN OR 60934-58-9/CRN OR 61812-10-0/CRN OR 644976-48-7/CRN OR<br>68404-37-5/CRN OR 70881-43-5/CRN OR 73145-42-3/CRN OR 75042-80-<br>7/CRN OR 75042-81-8/CRN OR 791121-04-5/CRN OR 85401-75-8/CRN<br>OR 875829-71-3/CRN OR 942078-48-0/CRN OR 94951-00-5/CRN) OR L3 |
| L7  | 85    | SEA FILE=CAPLUS ABB=ON   | PLU=ON | L5 AND L6  |
| L8  | 4     | SEA FILE=CAPLUS ABB=ON   | PLU=ON | L7 AND REM+NT/RL   |
| L9  | 82    | SEA FILE=CAPLUS ABB=ON   | PLU=ON | L1 AND L2  |
| L10 | 4     | SEA FILE=CAPLUS ABB=ON   | PLU=ON | L8 AND L9  |
| L11 | 4     | SEA FILE=CAPLUS ABB=ON   | PLU=ON | L8 OR L10  |
| L12 | 16428 | SEA FILE=CAPLUS ABB=ON   | PLU=ON | L6(L) (PURIF? OR REMOV? OR<br>REM/RL OR PUR/RL)  |
| L13 | 5     | SEA FILE=CAPLUS ABB=ON   | PLU=ON | L7 AND L12   |
| L14 | 35    | SEA FILE=CAPLUS ABB=ON   | PLU=ON | L5(L) (PURIF? OR PUR/RL OR<br>REMOV? OR REM/RL)  |
| L15 | 5     | SEA FILE=CAPLUS ABB=ON   | PLU=ON | L14 AND L7   |
| L16 | 5     | SEA FILE=CAPLUS ABB=ON   | PLU=ON | L11 OR L13 OR L15  |
| L17 | 10    | SEA FILE=CAPLUS ABB=ON   | PLU=ON | L7 AND (REMOV? OR PURIF?)  |
| L18 | 11    | SEA FILE=CAPLUS ABB=ON   | PLU=ON | L17 OR L16   |

L19           17 SEA FILE=CAPLUS ABB=ON PLU=ON L7 AND (REMOV? OR PURIF? OR  
?IMPUR?)  
 L20           18 SEA FILE=CAPLUS ABB=ON PLU=ON L19 OR L18  
 L21           66 SEA FILE=CAPLUS ABB=ON PLU=ON ("SOMMER C"/AU OR "SOMMER C  
A"/AU OR "SOMMER C C"/AU OR "SOMMER C IRENE"/AU OR "SOMMER C  
J"/AU OR "SOMMER C M"/AU OR "SOMMER C S"/AU OR "SOMMER  
CHRISTOPH"/AU OR "SOMMER CHRISTOPHER"/AU OR "SOMMER CHRISTOPHER  
C"/AU OR "SOMMER CHRISTOPHER CHARLES"/AU)  
 L22           2 SEA FILE=CAPLUS ABB=ON PLU=ON L21 AND ?SULF? AND ?FLUOR?  
 L23           1 SEA FILE=CAPLUS ABB=ON PLU=ON L22 AND L20  
 L25           1 SEA FILE=CAPLUS ABB=ON PLU=ON L22 NOT L23

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L25 ANSWER 1 OF 1 CAPLUS COPYRIGHT 2007 ACS on STN  
 ACCESSION NUMBER: 2007:1215080 CAPLUS Full-text  
 TITLE: Characterization of high molecular weight plasma  
protein complexes induced by clotting factor  
rFXIII-treatment in the cynomolgus monkey  
 AUTHOR(S): Schaal-Jensen, R.; Kiehr, B.; Boesen, H. T.; Krabbe,  
J. S.; Sommer, C.; Jacobsen, H.;  
Oleksiewicz, M. B.  
 CORPORATE SOURCE: Novo Nordisk A/S, Maalov, Den.  
 SOURCE: Journal of Thrombosis and Haemostasis (2007), 5(10),  
2070-2078  
 CODEN: JTTHOA5; ISSN: 1538-7933  
 PUBLISHER: Blackwell Publishing, Inc.  
 DOCUMENT TYPE: Journal  
 LANGUAGE: English

AB Background: In cynomolgus monkeys, suprapharmacol. doses of clotting recombinant factor XIII (rFXIII) cause a generalized coagulopathy, associated with formation of circulating high mol. weight protein complexes (HMEX). HMEX consist of plasma protein substrates cross-linked by FXIII transglutaminase activity. Objective: To characterize HMEX, with a view to develop safety biomarker assays. Methods: Cynomolgus monkeys received single i.v. injections with vehicle or rFXIII at 1, 3 and 10 mg kg<sup>-1</sup>. Plasma HMEX were analyzed by sodium dodecylsulfate-polyacrylmide gel electrophoresis, silver staining, Western blotting and quant. dissociation-enhanced lanthanide fluoroimmunoassay. Plasma FXIII antigen was analyzed by quant. ELISA. Human HMEX were made in vitro, by spiking plasma with thrombin-activated rFXIII. Results: Maximal circulating HMEX levels were reached within 1 h of rFXIII treatment, and remained stable over 24 h. HMEX above 250 kDa contained fibrinogen  $\alpha$ -chains and fibronectin. Fibrinogen  $\gamma$ -chain was detected only in HMEX below 250 kDa. The total plasma concentration of HMEX was in the low  $\mu$ g mL<sup>-1</sup> range, distributed on less than 20 main species. Human and cynomolgus HMEX were similar. HMEX formation increased with rFXIII dose in a disproportionate manner, with 3-fold and fortyfold increases in HMEX exposure associated with rFXIII dose increments from 1 to 3 and 3 to 10 mg kg<sup>-1</sup>, resp. Conclusions: The disproportionate HMEX formation parallels the steep toxicity dose response previously reported for rFXIII in cynomolgus monkeys, supporting a mechanistical role for HMEX in the generalized coagulopathy seen in rFXIII toxicity. Our findings support that HMEX constitute candidate (potential) safety biomarkers in rFXIII treatment.

REFERENCE COUNT: 19 THERE ARE 19 CITED REFERENCES AVAILABLE FOR THIS RECORD. ALL CITATIONS AVAILABLE IN THE RE FORMAT

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(FILE 'HOME' ENTERED AT 11:01:20 ON 15 NOV 2007)

FILE 'REGISTRY' ENTERED AT 11:01:40 ON 15 NOV 2007

E CARBON DIOXIDE/CN  
L1 1 SEA ABB=ON PLU=ON "CARBON DIOXIDE"/CN  
E SULPHURYL FLUORIDE/CN  
E F2O2S/MF  
L2 5 SEA ABB=ON PLU=ON F2O2S/MF  
D SCA  
D L1  
E CO2/MF  
L3 52 SEA ABB=ON PLU=ON CO2/MF  
SEL RN L2  
L4 17 SEA ABB=ON PLU=ON (12769-73-2/CRN OR 2699-79-8/CRN OR  
640723-20-2/CRN OR 855587-99-4/CRN OR 855588-00-0/CRN)  
L5 22 SEA ABB=ON PLU=ON L4 OR L2  
SEL RN L3  
L6 1396 SEA ABB=ON PLU=ON (10375-58-3/CRN OR 10375-59-4/CRN OR  
104120-67-4/CRN OR 1111-72-4/CRN OR 113869-22-0/CRN OR  
12181-61-2/CRN OR 12351-94-9/CRN OR 124-38-9/CRN OR 12709-62-5/  
CRN OR 138832-57-2/CRN OR 14485-07-5/CRN OR 182349-88-8/CRN OR  
182349-91-3/CRN OR 18983-82-9/CRN OR 20201-82-5/CRN OR  
20273-05-6/CRN OR 20273-06-7/CRN OR 22377-27-1/CRN OR 24285-82-  
3/CRN OR 243144-23-2/CRN OR 243144-24-3/CRN OR 243144-25-4/CRN  
OR 243144-26-5/CRN OR 243144-27-6/CRN OR 243144-28-7/CRN OR  
243144-29-8/CRN OR 2537-69-1/CRN OR 2684-00-6/CRN OR 270063-98-  
4/CRN OR 301299-78-5/CRN OR 31530-57-1/CRN OR 318953-55-8/CRN  
OR 34715-42-9/CRN OR 37210-16-5/CRN OR 37961-43-6/CRN OR  
39399-66-1/CRN OR 51-90-1/CRN OR 60605-62-1/CRN OR 60730-47-4/C  
RN OR 60934-58-9/CRN OR 61812-10-0/CRN OR 644976-48-7/CRN OR  
68404-37-5/CRN OR 70881-43-5/CRN OR 73145-42-3/CRN OR 75042-80-  
7/CRN OR 75042-81-8/CRN OR 791121-04-5/CRN OR 85401-75-8/CRN  
OR 875829-71-3/CRN OR 942078-48-0/CRN OR 94951-00-5/CRN) OR L3

FILE 'CAPLUS' ENTERED AT 11:04:00 ON 15 NOV 2007

L7 85 SEA ABB=ON PLU=ON L5 AND L6  
L8 4 SEA ABB=ON PLU=ON L7 AND REM+NT/RL  
D SCA TI  
L9 82 SEA ABB=ON PLU=ON L1 AND L2  
L10 4 SEA ABB=ON PLU=ON L8 AND L9  
L11 4 SEA ABB=ON PLU=ON L8 OR L10  
L12 16428 SEA ABB=ON PLU=ON L6(L) (PURIF? OR REMOV? OR REM/RL OR  
PUR/RL)  
L13 5 SEA ABB=ON PLU=ON L7 AND L12  
L14 35 SEA ABB=ON PLU=ON L5(L) (PURIF? OR PUR/RL OR REMOV? OR  
REM/RL)  
L15 5 SEA ABB=ON PLU=ON L14 AND L7  
L16 5 SEA ABB=ON PLU=ON L11 OR L13 OR L15  
L17 10 SEA ABB=ON PLU=ON L7 AND (REMOV? OR PURIF?)  
L18 11 SEA ABB=ON PLU=ON L17 OR L16  
D SCA TI  
L19 17 SEA ABB=ON PLU=ON L7 AND (REMOV? OR PURIF? OR ?IMPUR?)  
L20 18 SEA ABB=ON PLU=ON L19 OR L18  
E SOMMER C/AU  
L21 66 SEA ABB=ON PLU=ON ("SOMMER C"/AU OR "SOMMER C A"/AU OR  
"SOMMER C C"/AU OR "SOMMER C IRENE"/AU OR "SOMMER C J"/AU OR  
"SOMMER C M"/AU OR "SOMMER C S"/AU OR "SOMMER CHRISTOPH"/AU OR  
"SOMMER CHRISTOPHER"/AU OR "SOMMER CHRISTOPHER C"/AU OR  
"SOMMER CHRISTOPHER CHARLES"/AU)

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L22        2 SEA ABB=ON PLU=ON L21 AND ?SULF? AND ?FLUOR?  
L23        1 SEA ABB=ON PLU=ON L22 AND L20  
L24        18 SEA ABB=ON PLU=ON L20 OR L23  
L25        1 SEA ABB=ON PLU=ON L22 NOT L23

FILE 'CAPLUS' ENTERED AT 12:49:05 ON 15 NOV 2007

D QUE L24  
D L24 IBIB ABS HITIND HITSTR TOT  
D QUE L25  
D L25 IBIB ABS TOT